



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 10, 2026

IGI Report Number **LG816649224**

Description	LABORATORY GROWN DIAMOND
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Shape and Cutting Style **CUSHION MODIFIED BRILLIANT**

Measurements 6.53 X 5.25 X 3.40 MM

GRADING RESULTS

Carat Weight 1.07 CARAT

Color Grade **FANCY INTENSE YELLOW**

Clarity Grade VS 1

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

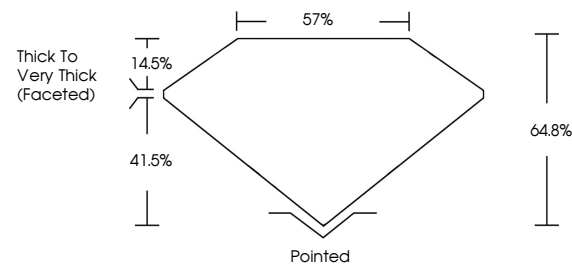
Fluorescence **NONE**

Inscription(s)  LG816649224

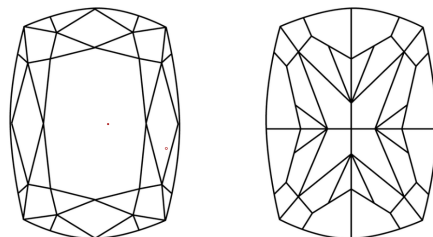
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

LG816649224
Report verification at igi.org

PROPORTIONS

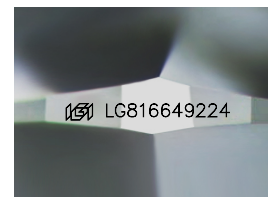


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

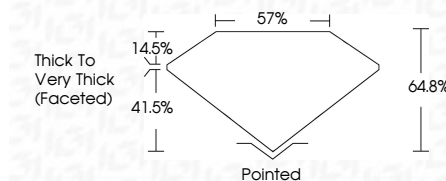
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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ADDITIONAL GRADING INFORMATION

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Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	(15) LG816649224

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www.igi.org